

Ultra Precision Manufacturing Conference 2015

Tuesday 12 May 2015

Institute for Manufacturing, Cambridge, Lecture Theatres

Agenda

08:45 – 09:15 Arrival and Registration

09:15 – 09:30	Welcome and Introduction Conference Team
09:30 – 09:50	Introduction to the TRL (Technology Readiness Level) Martin O'Hara, National Strategy Manager EPSRC Centre for Innovative Manufacturing in Ultra Precision
09:50 – 10:10	How to approach the next generation of Optical Instruments Prof. Richard Leach, University of Nottingham
10:10 – 10:30	The Latest Advances in High Precision Laser Micromachining Alan Ferguson, Oxford Lasers
10:30 – 11:00	BREAK
11:00 – 12:20	Ultra Precision PhD Presentations Centre for Innovative Manufacturing and Centre for Doctoral Training in Ultra Precision PhD Students
12:20 – 13:20	Networking Lunch
13:20 - 13:40	Nano Ploughing – A Scale up nanofabrication method Dr. Sun Jining, Heriot-Watt University
13:40 - 14:00	Nanoanalysis in the SEM: From nanolayer down to single atoms Christian Lang, Oxford Instruments
14:00 – 14:20	Nano-Metrology: X-rays, Optical Interferometry, AFM Metrology and Nano positioning Andrew Yacoot, National Physics Laboratory (NPL)
14:20 – 14:40	AFM Probed-Based Machining Dr. Emmanuel Brousseau, Cardiff University
14:40 – 15:10	BREAK
15:10 – 15:30	Challenges in Geometrical Metrology for Additive Manufacturing Prof. Xiangqian (Jane) Zhang, University of Huddersfield
15:30 – 15:50	Engineering of Surface using laser-initiated liquid-assisted colloidal lithography Dr. Magdalena Ulmeanu, University of Bristol
15:50 – 16:10	Ultra Precision Machining for Integrated Photonic Devices Dr. Lewis G. Carpenter, University of Southampton
16:10 – 16:30	PiMag 6D Levitation in Six Degrees of Freedom Kevin Grimley, PI UK Ltd
16:30 – 16:50	The marriage of robots and Zeeko machines - Steps towards a versatile, automated, manufacturing cell Richard Freeman, Zeeko Ltd
16:50 – 17:00	Closing Remarks Conference Team

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